

10/083585
02/27/02

U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10083585	FILING DATE 02/27/2002	CLASS 438	SUBCLASS	GAU 2812	EXAMINER 2829
**APPLICANTS: Iwasaki Yukiko; Shoji Tatsumi; Nishida Shoji;					
**CONTINUING DATA VERIFIED: None AKS					
** FOREIGN APPLICATIONS VERIFIED: Yes AKS JAPAN 076284/2001(PAT.) 03/16/2001 JAPAN 029299/2002(PAT.) 02/06/2002					
PG-PUB		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>	
Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no			ATTORNEY DOCKET NO		
35 USC 119 conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no			03560.002998		
Verified and Acknowledged Examiners's initials AKS					
TITLE : Method for manufacturing a semiconductor film					
U.S. DEPT. OF COMM./PAT & TM-PTO-436L (Rev. 12-94)					

NOTICE OF ALLOWANCE MAILED		Assistant Examiner		CLAIMS ALLOWED	
				Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner		DRAWING	
Amount Due	Date Paid			Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE		Application Examiner	
WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.					

FILED WITH:

☐ DISK (CRF)

☐ CD-ROM

(Attached in pocket on right inside flap)